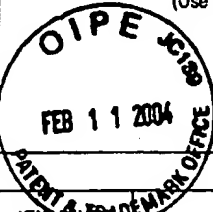
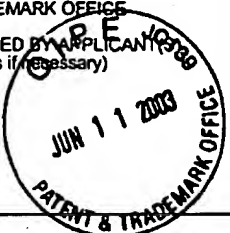
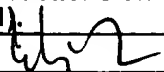


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		APPLICANT ADAM MICHAEL BAUMBERG					
		FILING DATE October 19, 2001		GROUP 2621			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>W</i>		2002/0085748 A1	07/04/92	Baumberg	382	154	
<i>Cml</i>		2003/0001837 A1	01/02/03	Baumberg	345	449	
FOREIGN PATENT DOCUMENTS						RECEIVED FEB 12 2004 Technology Center 2600	
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
<i>Cml</i>	JP	11-328441 A	11/30/99	Japan	G06T	15/70	Abstract
<i>Cml</i>	JP	2000-268189 A	09/29/00	Japan	G06F	15/00	Abstract
<i>Cml</i>	WO	98/18117	04/30/98	PCT	G09G	A2	Eng. Orig.
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Cml</i>		J. D. Foley et al., "Computer Graphics Principles and Practice", Addison-Wesley Pub. Co., Second Ed., Section 16.3.2, pp. 741-744 (1997).					
<i>Cml</i>		P. J. Sloan et al., "Importance Driven Texture Coordinate Optimization", Eurographics '98, Vol. 17, No. 3 (1998).					
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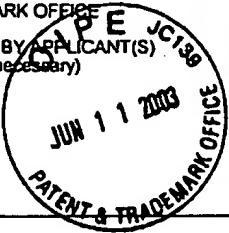
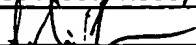
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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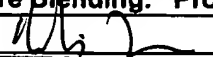
Sheet 1 of 1

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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)						
Cm		Wolfgang Niem et al., "Automatic Reconstruction of 3D Objects Using a Mobile Monoscopic Camera." Image and Vision Computing 17, pp. 125-134. (1999).				
Cm		Peter J. Burt et al., "A Multiresolution Spline with Application to Image Mosaics." ACM Transactions on Graphics (TOG), Vol. 2, No. 4, pp. 217-236 (October 1983).				
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Cm		Fausto Bernardini et al., "High-Quality Texture Reconstruction from Multiple Scans." IEEE Transactions on Visualization and Computer Graphics, Vol. 7, No. 4, pp. 318-332 (Oct.-Dec. 2001).				
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			EM 10-17-05			

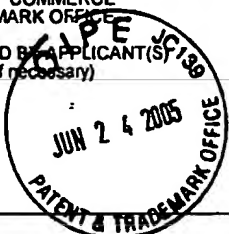
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Cml		Eyal Ofek et al., "Multiresolution Textures from Image Sequences." IEEE Computer Graphics and Applications, Vol. 17, No. 2, pp. 18-29 (March 1997).					
Cml		Igor Guskov et al., "Multiresolution Signal Processing for Meshes." In Conference Proceedings ACM SIGGRAPH, pp. 325-334 (1999).					
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Cml		Pedro V. Sander et al., "Texture Mapping Progressive Meshes." In Conference Proceedings ACM SIGGRAPH, pp. 409-423 (August 2001).					
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Cml		Maneesh Agrawala et al., "Efficient Image-Based Methods for Rendering Soft Shadows." Proceeding of SIGGRAPH 2000, Computer Graphics Proceedings, Annual Conference Series, pp. 375-384 (July 2000).					
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		FILING DATE October 19, 2001		GROUP 2621					
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Cml		Yizhou Yu., "Efficient Visibility Processing for Projective Texture Mapping." Computer & Graphics, Vol. 23, pp. 245-253 (1999).							
Cml		Reinhard Koch et al., "Multi Viewpoint Stereo from Uncalibrated Video Sequences." ECCV '98, vol. I, pp. 55-71 (June 1998).							
Cml		C. Rocchini et al., "Multiple Textures Stitching and Blending on 3D Objects." Eurographics Rendering Workshop, (June 1999).							
Cml		Hendrik P. A. Lensch, "A Silhouette-Based Algorithm for Texture Registration and Stitching." Graphical Models, Vol. 63, No. 4, pp. 245-262 (2001).							
Cml		Wojciech Matusik et al., "Image-Based Visual Hulls." Proceedings of SIGGRAPH 2000, pp. 369-374 (2000).							
Cml		Dan Piponi et al., "Seamless Texture Mapping of Subdivision Surfaces by Model Pelting and Texture Blending." Proceeding of SIGGRAPH 2000, pp. 471-478 (July 2000).							
EXAMINER				DATE CONSIDERED					
				10-17-05					

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		APPLICANT ADAM MICHAEL BAUMBERG					
		FILING DATE October 19, 2001		GROUP 2623			
U.S. PATENT DOCUMENTS							
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<i>Cml</i>	JPA	7-254072 A	10/03/95	Japan			Abstract
<i>Cml</i>	JPA	6-348860 A	12/22/94	Japan			Abstract
<i>Cml</i>	JPA	2001-126084 A	05/11/01	Japan			Abstract
<i>Cml</i>	JPA	11-120372 A	04/30/99	Japan			Abstract
<i>Cml</i>	JPA	8-147494 A	06/07/96	Japan			Abstract
<i>Cml</i>	JPA	2000-348196	12/15/00	Japan			Abstract
<i>Cml</i>	JPA	7-230555	08/29/95	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER <i>ML-2</i>				DATE CONSIDERED <i>10-17-05</i>			

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Sheet 1 of 1